

35.G2758



S. Stevanoff
8-17-01 #4
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
RYUICHI EBINUMA, ET AL.) Examiner: UNASSIGNED
Application No.: 09/817,018) Group Art Unit: 2812
Filed: March 27, 2001)
For: SUPPORTING STRUCTURE OF) June 21, 2001
OPTICAL ELEMENT, EXPOSURE :
APPARATUS HAVING THE)
SAME, AND MANUFACTURING :
METHOD OF SEMICONDUCTOR)
DEVICE` :
:

Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.


Japanese patent document No. 2000-66075 has been discussed on page 4 of the subject specification.



Applicants request that the above information be considered by the Examiner and that an initialed copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,


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